

Notice of References Cited

Application/Control No.

09/582,630

Applicant(s)/Patent Under
Reexamination
DI CIOCCIO, LEA DI

Examiner

Caridad M. Everhart

Art Unit

2825

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U.S. PATENT DOCUMENTS

*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
	A	US-5,563,428	10-1996	Guarin, et al.	257-	-77-
	B	US-				
	C	US-				
	D	US-				
	E	US-				
	F	US-				
	G	US-				
	H	US-				
	I	US-				
	J	US-				
	K	US-				
	L	US-				
	M	US-				

FOREIGN PATENT DOCUMENTS

*		Document Number	Date	Country	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY				
	N						
	O						
	P						
	Q						
	R						
	S						
	T						

NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U	Tong, Q, et al. "A feasibility study of SiC on oxide by wafer bonding and layer transferring" Proc. Int. SOI Conf., Palm Springs, Oct. 1993 pp. 60-61.				
	V	DiCioccio, L. et al. "Silicon carbide on insulator formation by the smart-cut process", Mat. Sci. & Eng. B Vol. 46, No. 1-3, April 1997 pp. 349-356.				
	W					
	X					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.